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CONFIRMATION NO. 3939

<b>SERIAL NUMBER</b> 10/510,695	<b>FILING OR 371(c) DATE</b> 10/08/2004 <b>RULE</b>	<b>CLASS</b> 117	<b>GROUP ART UNIT</b> 1765	<b>ATTORNEY DOCKET NO.</b> 121356	
<b>APPLICANTS</b> Izumi Fusegawa, Fukushima, JAPAN; Sadayuki Okuni, Fukushima, JAPAN; Nobuaki Mitamura, Fukushima, JAPAN; Tomohiko Ohta, Fukushima, JAPAN; Nobuo Katuoka, Fukushima, JAPAN;					
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/05167 04/23/2003					
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-122250 04/24/2002					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 3	<b>TOTAL CLAIMS</b> 9	<b>INDEPENDENT CLAIMS</b> 3
Verified and Acknowledged Examiner's Signature _____ Initials _____					
<b>ADDRESS</b> 25944					
<b>TITLE</b> Method for producing silicon single crystal and, silicon single crystal and silicon wafer					
<b>FILING FEE RECEIVED</b> 950	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		